## **AMENDMENTS TO THE CLAIMS**

1. (Currently Amended) A mems transducer comprising:

a printed circuit board comprising a plurality of layers, at least one layer comprising a conductive material and at least one layer comprising an insulating material;

a cover comprising a conductive layer, the printed circuit board and the cover forming at least a portion of a housing, the housing comprising an aperture for receiving a signal and an inner lining for providing a shield against an electromagnetic interference[[,]] being formed by the conductive layer and the at least one layer of a conductive material; and

a spacer member between the printed circuit board and the cover, the spacer member cooperating with the printed circuit board and the cover to form the housing, the spacer member comprising a sidewall at least partially covered by a conductive material, the conductive material providing a portion of the inner lining; and

a transducer unit mounted within the housing.

- 2. Canceled.
- 3. (Currently Amended) The mems transducer of Claim [[2]] 1 further comprising a first layer of conductive adhesive for joining the spacer member to the cover.
- 4. (Previously Presented) The mems transducer of Claim 3 further comprising a second layer of conductive adhesive for joining the spacer member to the circuit board.
- 5. (Previously Presented) The mems transducer of Claim 1 further comprising an environmental barrier located within the aperture.
- 6. (Previously Presented) The mems transducer of Claim 5 wherein the aperture is within the cover, the cover comprising a nonconductive layer for providing the environmental barrier.

- 7. (Previously Presented) The mems transducer of Claim 5 wherein the aperture is located within the cover, the cover comprising a polymeric layer for providing the environmental barrier.
- 8. (Previously Presented) The mems transducer of Claim 5 wherein the aperture is located within the ed circuit board, the printed circuit board comprising a polymeric layer for providing the environmental barrier.
- 9. (Previously Presented) The mems transducer of Claim 5 wherein the environmental barrier comprises a polymeric material.
- 10. (Previously Presented) The mems transducer of Claim 9 wherein the polymeric material is a film.
- 11. (Previously Presented) The mems transducer of Claim 10 wherein the film comprises a polytetrafluoroethylene.
- 12. (Previously Presented) The mems transducer of Claim 1 wherein the conductive material comprises copper.
- 13. (Previously Presented) The mems transducer of Claim 1 wherein the printed circuit board comprises a plurality of layers of a conductive material and a plurality of layers of an insulating material.
- 14. (Previously Presented) The mems transducer of Claim 13 wherein one of the plurality of layers of a conductive material comprises a pair of lead pads for electrical connection to the transducer unit.
- 15. (Previously Presented) The mems transducer of Claim 14 wherein one of the plurality of layers of a conductive material provides a first electrical ground plane.
- 16. (Previously Presented) The mems transducer of Claim 15 wherein one of the plurality of layers of a conductive material provides a second electrical ground plane.

17. (Previously Presented) The mems transducer of Claim 16 wherein the first and second ground planes are electrically connected to the pair of lead pads.

- 18. (Previously Presented) The mems transducer of Claim 17 wherein one of the plurality of layers of a conductive material comprises a pair of connectors for electrical connection to an external transducer.
  - 19. (Currently Amended) A mems transducer comprising:

a transducer unit; and

a housing substantially covering the transducer unit and providing protection against an electromagnetic interference, the housing comprising a substrate, a spacer and a cover forming an interior of the housing in which the transducer unit is disposed, each of the substrate, the spacer and the cover comprising a first layer of a non-conductive material and a second layer of a conductive material substantially covering the first layer of non-conductive material, the second conductive layers being electrically coupled and substantially forming an inner lining of the housing, the housing further comprising an aperture for receiving a signal into the housing.

- 20. (Currently Amended) The mems transducer of Claim 19 further comprising a third layer of a nonconductive material, the third layer substantially covering the aperture for providing an environmental barrier.
- 21. (Currently Amended) The mems transducer of Claim 20 wherein the third aperture covering layer comprises a polymeric material.
- 22. (Previously Presented) The mems transducer of Claim 21 wherein the polymeric material is a polytetrafluoroethylene.
- 23. (Previously Presented) The mems transducer of Claim 19 further comprising a retaining ring, the transducer unit engaging the retaining ring.

24. (Currently Amended) A silicon mems transducer comprising: a transducer unit;

a substrate including an upper surface having a recess formed therein, the transducer unit attached to the upper surface of the substrate overlapping at least a portion of the recess wherein a back volume of the transducer unit is formed between the transducer unit and the substrate; and

a cover placed over the transducer unit, the cover including an aperture; and

a spacer disposed between the substrate and the cover, each of the substrate, the spacer and the cover comprising a layer of conductive material the conductive layers being electrically coupled and substantially forming an inner, shielding lining.

25. (Currently Amended) A silicon mems transducer comprising:

a transducer unit;

a substrate including an upper surface for supporting the transducer unit;

a cover placed over a portion of the substrate, the cover comprising an aperture and an inner surface,

a spacer disposed between the substrate and the cover, the spacer having in inner surface; and

a portion of the <u>cover</u> inner surface <u>and the spacer inner surface</u> comprising a metallic material for shielding the transducer unit from an interference signal.

26. (Currently Amended) A mems transducer comprising:

a transducer unit:

a substrate including an upper surface for supporting the transducer unit;

a cover sealed over a portion of the substrate, the cover having an aperture for receiving a signal;

<u>a spacer disposed between the substrate and the cover, the spacer having in inner surface;</u> and

an a cover inner surface and a spacer inner surface each comprising a shielding material for protecting the transducer from an interference signal.

27. (Currently Amended) A mems transducer comprising:

a transducer unit;

a substrate comprising a layer of an insulating material and a layer of conductive material, the substrate further comprising a surface for supporting the transducer unit;

a cover placed over a portion of the substrate;

a spacer disposed between the substrate and the cover; and

the cover <u>and spacer each</u> comprising a shielding material for protecting the transducer from an interference signal.

28. (Currently Amended) A mems transducer comprising:

a printed circuit board comprising a first insulating layer and a first conductive layer; a transducer unit supported by the printed circuit board; and

a cover over a portion of the printed circuit board and forming a housing therewith for protecting the transducer unit, the cover comprising an aperture, a second insulating layer, and a second conductive layer, a portion of the second conductive layer

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exposed to a conductive spacer and electrically connected to a ground via [[the]]  $\underline{a}$  conductive spacer for shielding the transducer from an interference signal.

29. (Previously Presented) A mems transducer comprising:

a printed circuit board comprising a first insulating layer, a first conductive layer, and an aperture;

a transducer unit; and

a cover over a portion of the printed circuit board and forming a housing therewith for protecting the transducer unit, the cover comprising a second insulating layer and a second conductive layer, a portion of the second conductive exposed to a conductive spacer and electrically connected to a ground via the conductive spacer for shielding the transducer from an interference signal.

30. (Previously Presented) A mems transducer housing for a silicon mems transducer, the mems transducer housing comprising:

an inner lining for providing a shield from an electromagnetic interference, the inner lining comprising an aperture adapted for receiving an acoustic signal;

a circuit board comprising a first insulating layer and a first conductive layer, the first conductive layer forming at least a portion of the inner lining; and

a cover comprising a second conductive layer forming at least a portion of the inner lining; and

a spacer member disposed between the circuit board and the cover, the spacer member including, the spacer member comprising a sidewall including a third conductive layer forming a portion of the inner lining, wherein the first conductive layer, the second conductive layer and the third conductive layer are electrically coupled to form the inner lining.

31 - 38 Canceled.

- 39. (Currently Amended) The mems transducer of Claim 3 wherein the conductive adhesive may or may not form a continuous gasket between the spacer member and the cover.
- 40. (Previously Presented) The mems transducer of Claim 4 wherein the conductive adhesive may or may not form a continuous gasket between the spacer member and the circuit board.
- 41. (Previously presented) The mems transducer Claim 1 wherein the printed circuit board includes an upper surface having a recess formed therein, the transducer unit attached to the upper surface of the printed circuit board overlapping at least a portion of the recess wherein a back volume of the transducer unit is formed between the transducer unit and the printed circuit board.
- 42. (Previously presented) The mems transducer Claim 1 wherein the printed circuit board includes a pocket formed therethrough, the transducer unit attached to the printed circuit board and overlapping at least a portion of the pocket wherein a back volume of the transducer unit is formed by cooperation of the transducer unit and the pocket.